

**Notice of References Cited**

Application/Control No.

09/872,772

Applicant(s)/Patent Under  
Reexamination  
ZIMMEL, STEVEN C.

Examiner

Hae M Hyeon

Art Unit

2839

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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-4,995,688	02-1991	Anton et al.	385/53
	B	US-5,113,462	05-1992	Clancy et al.	385/53
*	C	US-5,214,735	05-1993	Henneberger et al.	385/136
	D	US-5,542,015	07-1996	Hultermans, Antonius P. C. M.	385/60
	E	US-5,633,963	05-1997	Rickenbach et al.	385/25
	F	US-5,642,450	06-1997	Oda, Gan	385/60
	G	US-5,737,464	04-1998	Underwood et al.	385/72
	H	US-5,805,760	09-1998	Serafini et al.	385/147
	I	US-5,960,139	09-1999	Henning, Wolfram	385/78
	J	US-6,048,103	04-2000	Furukata et al.	385/73
	K	US-6,102,581	08-2000	Deveau et al.	385/56
	L	US-6,275,643	08-2001	Bandy et al.	385/140
	M	US-6,461,055	10-2002	Zimmel, Steven C.	385/73

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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	V	
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	X	

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